



Beam Diagnostics

Ulrich Raich CERN BE - BI (Beam Instrumentation)

Overview

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• First hour:

- Introduction

- Overview of measurement instruments

- Faraday Cup
- Beam Current Transformer
- Beam Position Monitor
- Profile Detectors
 - SEMGrids
 - Wire Scanners
- Beam Loss Monitors
- · Second hour

- Some depicted examples of beam parameter measurements

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Introduction



An accelerator can never be better than the instruments measuring its



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Different uses of beam diagnostics



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- Regular crude checks of accelerator performance
 - Beam Intensity
 - Radiation levels
- Standard regular measurements
 - Emittance measurement
 - Trajectories
 - Tune

Sophisticated measurements e.g. during machine development sessions

- May require offline evaluation
- May be less comfortable



Diagnostic devices and quantity measured



Instrument	Physical Effect	Measured Quantity	Effect on beam
Faraday Cup	Charge collection	Intensity	Destructive
Current Transformer	Magnetic field	Intensity	Non destructive
Wall current monitor	Image Current	Intensity Longitudinal beam shape	Non destructive
Pick-up	Electric/magnetic field	Position	Non destructive
Secondary emission monitor	Secondary electron emission	Transverse size/shape, emittance	Disturbing, can be destructive at low energies
Wire Scanner	Secondary particle creation	Transverse size/shape	Slightly disturbing
Scintillator screen	Atomic excitation with light emission	Transverse size/shape (position)	Destructive
Residual Gas monitor	Ionization	Transverse size/shape	Non destructive

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Required Competence in a beam diagnostics group



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- Some beam physics in order to understand the beam parameters to be measured and to distinguish beam effects from sensor effects
- Detector physics to understand the interaction of the beam with the sensor
- Mechanics
- Analogue signal treatment
 - Low noise amplifiers
 - High frequency analogue electronics
- Digital signal processing
- Digital electronics for data readout
- Front-end and Application Software

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Electro-static Field in Faraday Cup



In order to keep secondary electrons with the cup a repelling voltage is applied to the polarization electrode

Since the electrons have energies of less than 20 eV some 100V repelling voltage is sufficient



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Energy of secondary emission electrons



- With increasing repelling voltage the electrons do not escape the Faraday Cup any more and the current measured stays stable.
- At 40V and above no decrease in the Cup current is observed any more



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веам ≈ 20 µА

M 100µs Ext 1 404mV

- The calibration signal is injected into a separate calibration winding
- A calibration procedure executed before the running period
- A calibration pulse before the beam pulse measured with the beam signal

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100mV







Display of transformer readings



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- First result from LHC FBCT
- Measurement of bunch intensity
- Diminishing intensity due to debunching
- Beam losses will trigger machine protection system





The DC current transformer



- AC current transformer can be extended to very long droop times but not to DC
- Measuring DC currents is needed in storage rings
- Must provide a modulation frequency
- Takes advantage of non/linear magnetisation curve



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Modulation current difference signal with beam



- Difference signal has $2\omega_m$
- ω_m typically 200 Hz 10 kHz
- Use low pass filter with $\omega_c{<}\omega_m$
- Provide a 3rd core, normal AC transformer to extend to higher frequencies



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National Research Foundation

Photo of DCCT internals



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Measuring Beam Position – The Principle





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Slide by R. Jones 28











If the beam is much smaller than w, all field lines are captured and U is a linear function with replacement else: Linear cut (projection to measurement plane must be linear)

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Doubly cut shoebox



- · Can measure horizontal and vertical position at once
- · Has 4 electrodes



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- Average force in transverse direction <> 0
- Mostly large impact parameter
 => low energy of ejected
 electron
- Electron mostly ejection transversely to the particle motion



Bethe Bloch formula

$$-\frac{dE}{dx} = 4\pi N_{A}r_{e}^{2}m_{e}c^{2}\frac{Z_{T}}{A_{T}}\rho\frac{Z_{p}^{2}}{\beta^{2}}\left[\ln\frac{2m_{e}c^{2}\gamma^{2}\beta^{2}}{I} - \beta^{2}\right]$$
• with the following constants:
NA: Avogadro's number
 m_{e} and r_{e} : electron rest mass and classical electron radius
 c : speed of light
• the following target material properties:
 p : material density
 A_{T} and Z_{T} : the atomic mass and nuclear charge
• and the particle properties:
 Z_{p} : particle charge

β: the particles velocity and $\gamma = \sqrt{1 - \beta^2}$

Dependance on Z_p^2

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Heavy ions at low energy are stopped within a few micro-meters All energy is deposited in a very small volume

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Scintillating Screens National Research Foundation Method already applied in cosmic ray experiments ITF line Very simple ٠ Temperate Very convincing • Needed: Scintillating Material ٠ ITE line TV camera • um valve In/out mechanism • Problems: Radiation resistance • CCD ea of TV camera Heating of screen (absorption of ٠ beam energy) Evacuation of electric charges ٠

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Degradation of screen



Degradation clearly visible However sensitivity stays essentially the same





Screen mechanism



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• Screen with graticule



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Results from TV Frame grabber National Research Foundation = First full turn as seen by the Num - L/V mm 100 BTV 10/9/2008 40 - 13 Same - 13 Uncaptured 100 -100 beam sweeps through he dump line O tes la tave

> For further evaluation the video signal is digitized, read-out and treated by program



Profile measurements



Secondary emission grids (SEMgrids)

When the beam passes secondary electrons are ejected from the ribbons

The current flowing back onto the ribbons is measured

Electrons are taken away by polarization voltage

One amplifier/ADC chain channel per ribbon

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Projection of charge density projected to x or y axis is

One amplifier/ADC per wire Large dynamic range

Resolution is given by wire

Used only in transfer lines

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Wire Scanners



A thin wire is quickly moved across the beam Secondary particle shower is detected outside the vacuum chamber on a scintillator/photo-multiplier assembly Position and photo-multiplier signal are recorded simultaneously





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The Linac beam (160 mA, 200 $\mu s,$ 50 MeV, 1Hz) is enough to burn a hole into the vacuum chamber

What about the LHC beam: 2808 bunches of 15*10¹¹ particles at 7 TeV? 1 bunch corresponds to a 5 kg bullet at 800 km/h



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Fermi Lab'sTevatron has 200 times less beam power than LHC!



Beam Loss Monitor Types

- · Design criteria: Signal speed and robustness
- Dynamic range (> 10⁹) limited by leakage current through insulator ceramics (lower) and saturation due to space charge (upper limit).

Secondary Emission Monitor Ionization chamber:

- (SEM):
- Length 10 cm
- P < 10⁻⁷ bar
- ~ 30000 times smaller gain



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- Parallel electrodes (AI, SEM:
 - Voltage 1.5 kV

- N₂ gas filling at 100 mbar

- Sensitive volume 1.5 l

- Ion collection time 85 μ s

Ti) separated by 0.5 cm - Low pass filter at the HV

over-pressure

- Length 50 cm

Both monitors:

input









Beam loss must be measured all around the ring => 4000 sensors!

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